

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	Group Art Unit: 2624
Kazuya FUKUHARA)	
)	Examiner: Mia M. THOMAS
Application No.: 10/776,591)	
)	
Filed: February 12, 2004)	Confirmation No.: 3478
)	
For: INSPECTION METHOD, PROCESSOR)	
AND METHOD FOR MANUFACTURING)	
A SEMICONDUCTOR DEVICE)	

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AND RESPONSE TO OFFICE ACTION

In reply to the Office Action mailed March 5, 2008, the period for response to which extends through June 5, 2008, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper beginning on page 2.

Remarks follow the amendment section of this paper beginning on page 8.